

**Notice of References Cited**

Application/Control No.

10/623,900

Applicant(s)/Patent Under  
Reexamination  
KUKULKA ET AL.

Examiner

Anthony Fick

Art Unit

1753

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,124,455 A	11-1978	Lindmayer, Joseph	438/98
*	B	US-4,468,853 A	09-1984	Morita et al.	438/72
*	C	US-5,330,585 A	07-1994	Chang et al.	136/256
*	D	US-5,928,438 A	07-1999	Salami et al.	136/255
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Studer, V., Pepin, A., Chen, Y., Ajdari, A., "Fabrication of microfluidic devices for AC electrokinetic fluid pumping", Microelectronic Engineering, 61-62, 2002, pgs 915-920.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.